



제 31회 한국반도체학술대회

The 31st Korean Conference on Semiconductors

2024년 1월 24일(수)-26일(금) | 경주화백컨벤션센터(HICO)

2024년 1월 26일(금), 15:40-17:25

Room I(203), 2층

D. Thin Film Process Technology 분과

[FI3-D] Emerging Films Growth Technique

좌장: 엄태용 선임(한국화학연구원), 한정환 교수(서울과학기술대학교)

초청발표 FI3-D-1 15:40-16:10	Multifunctional Oxide Thin Films for Novel Electronics Seung-Hyub Baek Electronics Materials Research Center, KIST
초청발표 FI3-D-2 16:10-16:40	High-quality Thin Film Quantum Materials Yoon Jang Chung Department of Chemical and Biological Engineering, Korea University
FI3-D-3 16:40-16:55	Revolutionizing SnS Thin Films Fabrication for Advanced Electronics Seung Ho Ryu ^{1,2} , Minki Choe ³ , Taeyong Eom ⁴ , Taek-Mo Chung ⁴ , In-Hwan Baek ³ , and Seong Keun Kim ^{1,2} ¹ KU-KIST Graduate School of Converging Science and Technology, Korea University, ² Electronic Materials Research Center, KIST, ³ Department of Chemical Engineering, Inha University, ⁴ Division of Advanced Materials, KRICT